

Übungen zur Oberflächenphysik Blatt 6 – 15.5.2012

- 1) Calculate the force and the spring constant between atoms from the Lennard-Jones potential as a function of distance:

$$V = 4\varepsilon \left(\left(\frac{\sigma}{r} \right)^{12} - \left(\frac{\sigma}{r} \right)^6 \right)$$

Use $\varepsilon = 0.4\text{eV}$, $\sigma = 3\text{\AA}$ and calculate the equilibrium distance r_k . Compare with the Morse potential:

$$V = U_0 \left(\exp\left(-\frac{2(r-s_0)}{\lambda}\right) - 2\exp\left(-\frac{(r-s_0)}{\lambda}\right) \right)$$

$$U_0 = 2\text{eV}, \lambda = 2\text{\AA}.$$

- 2) Based on the forces of the Lennard-Jones potential in 1):
- Discuss the forces that act during an AFM experiment in a vacuum between the tip and sample.
 - Discuss what effects (additional forces) may occur when the AFM experiment is carried out in the air, a solution,
- 3) Derive the formula for the force measured by Kelvin Probe Force Microscopy between the AFM tip and sample surface. The energy of the capacitor is $E = (1/2)CV^2$. What is the breakdown voltage limit for the capacitor made by the AFM tip and the sample surface in the air and in the UHV.
- 4) A silicon cantilever used in a non-contact AFM has a spring constant $k = 50\text{ N/m}$ and a mechanical resonance frequency $f_0 = 175\text{ kHz}$. Estimate the mass of the cantilever.
- 5) A cantilever with a force constant of 0.1 N/m is scanned across a surface in constant height mode. What will be the change in force as it passes over a bump of height 100 nm ?
- 6) In contrast to STM, the AFM is also sensitive to long range forces.
- Determine the van der Waals and the electrostatic forces of a sphere (radius $r = 10\text{ nm}$, Hamaker constant $H = 10^{-19}\text{ J}$, distance between tip and sample 0.5 nm , potential $U = 1\text{ V}$).
 - Calculate the corresponding frequency shifts.